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Docket No. 206342US2
IN RE APPLICATION OF: Toshifumi NAGAIWA, et al.
SERIAL NO: 09/840,178
FILED: April 24, 2001
FOR: WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
☒ Additional documents filed herewith: Marked-up Copy, Letter to Official Draftsman, Drawings (1 Sheet)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	18	MINUS	20	0	x \$18 =	\$0.00
INDEPENDENT	4	MINUS	3	1	x \$84 =	\$84.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$84.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$84.00

- ☒ A check in the amount of **\$84.00** is attached.
☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO.: 206342US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TOSHIFUMI NAGAIWA, ET AL. : EXAMINER: 1763
SERIAL NO: 09/840,178 :
FILED: APRIL 24, 2001 : GROUP ART UNIT: KACKAR, R.

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9/25/02
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FOR: WORKTABLE DEVICE AND :
PLASMA PROCESSING
APPARATUS FOR
SEMICONDUCTOR PROCESS

LETTER REQUESTING APPROVAL OF DRAWING CHANGES

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, DC 20231

SIR:

Please review for approval the proposed change to the Formal Drawings shown in
RED on the attached photocopy of the drawings (1 sheet).

Once this change has been reviewed and approved by the Examiner in charge of this
case, instructions for its implementation will be forwarded to an approved bonded draftsman.

Respectfully submitted,
OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Gregory J. Maier
Registration No: 25,599
Attorney of Record
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